

C1
C2

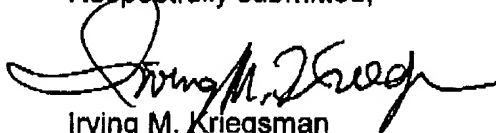
[b.] (b) detecting at least some of the light scattered from the area illuminated but not specularly reflected light as said semiconductor wafer is moving using a lens and CCD camera having a square array sensor and operational in a time delayed integration model.

REMARKS

The purpose of this Supplemental Amendment is to make the marked up version of claim 19 appearing on pages 20 and 21 of the Amendment dated June 3, 2003 consistent with the amended version of claim 19 as shown on page 9 of that Amendment.

Allowance of the application with claims 1-21 is earnestly solicited.

Respectfully submitted,


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I hereby certify that this correspondence is being sent by facsimile to Examiner Gordon Stock at FAX No. (703) 308-7722 on July 16, 2003.


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